



Docket No. BARDP0124US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

Applicant(s): Kai Numssen et al.

Serial No: 10/684,811

Filed: October 14, 2003

Title: METHOD FOR MANUFACTURE OF A HIGH TEMPERATURE SUPERCONDUCTING LAYER

Art Unit:

Examiner:

**INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

1. Pursuant to 37 C.F.R. 1.97 and 1.98, and in compliance with 37 C.F.R. 1.56, the Office's attention is directed to the patents, pending applications, publications and other information listed on the attached PTO-1449. A copy of each listed document is enclosed, except for (a) those previously cited or submitted to the Office in the following application(s) upon which this application relies for an earlier filing date under 35 U.S.C. 120, and (b) any U.S. patent or U.S. patent application publication if the present application was filed after June 30, 2003 or entered the national stage under 35 USC § 371 after June 30, 2003:

Serial No.: \_\_\_\_\_  
Filing Date: \_\_\_\_\_  
\_\_\_\_\_

Regarding any document, publication or other information for which a date is not given on the attached PTO-1449, Applicant(s) believe(s) the same may qualify as "prior" art to this application and should be treated accordingly, although Applicant(s) reserve(s) the right to contest the prior art status of any document, publication or information, should issue arise.

2. Regarding each listed document that is not in the English language, an English-language translation accompanies this Statement as indicated on the attached PTO-1449 or a concise explanation of the relevance of the document is set forth in the following document(s):

(a)  A copy of each English language version of a search report (or EPO Search Report) indicating the degree of relevance found by the foreign office of each document being submitted from the search report, is being submitted herewith or has previously been submitted.

(b)  Attached is a "Concise Explanation of Relevance of Non-English Language Documents".

3. Pursuant to 37 C.F.R. 1.97(b) this Statement is being filed (one must be checked):

(a)  Within 3 months of the filing date or date of entry into the National Stage.

(b)  Before the mailing date of a first Office Action on the merits. If this Statement is not filed before the mailing date of a first Office Action on the merits, the required certification is given below or, in the absence thereof, the Office is authorized to charge the required fee set forth in 37 C.F.R. 1.17(p) to Deposit Account No. 18-0988 for consideration of this Statement.

(c)  Before the mailing date of a first Office Action on the merits after a first or second submission after final rejection under 37 C.F.R. 1.129(a).

(d)  After the period set forth in 37 C.F.R. 1.97(b) but before the mailing date of either a final action or a notice of allowance.

(1)  The required certification is given below, or

(2)  Enclosed is a check covering the fee set forth in 37 C.F.R. 1.17(p) for consideration of this Statement, or

(3)  Charge the fee set forth in 37 C.F.R. 1.17(p) to Deposit Account No. 18-0988

(e)  After the mailing date of either a final action or a notice of allowance, but before payment of the issue fee. Petition hereby is made for consideration of this Statement and the required certification is indicated below.

(1)  Enclosed is a check covering the fee set forth in 37 C.F.R. 1.17(p), or

(2)  Charge the fee set forth in 37 C.F.R. 1.17(p) to Deposit Account No. 18-0988.

4. Certification (if applicable)

(a)  The undersigned hereby certifies that each item of information contained in this Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than 3 months prior to the filing of this Statement.

(b)  The undersigned hereby certifies that no item of information contained in this Statement was cited in a communication from a foreign patent office in a counterpart foreign application, and, to the undersigned's knowledge after making reasonable inquiry, no item of information contained in this statement was known to any individual designated in 37 C.F.R. 1.56(c) more than 3 months prior to the filing of this Statement.

5. The Commissioner is hereby authorized to charge any additional fees or credit any overpayment to Deposit Account No. 18-0988.

Respectfully submitted,

RENNER, OTTO, BOISSELLE & SKLAR, LLP

By   
Don W. Bulson, Esq.  
Reg. No. 28,192

1621 Euclid Avenue, 19th Floor  
Cleveland, Ohio 44115  
(216) 621-1113

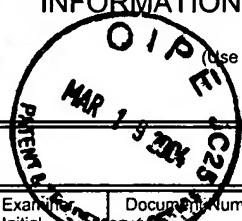
**CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8**

I hereby certify that this correspondence (along with any paper referenced as being attached or enclosed) is being deposited on the below date with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date: 3-15-04

  
Jennifer A. Moore

Form PTO-1449 (Modified)		Atty Docket No.	Serial No.
<b>LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT</b> <small>(Use several sheets if necessary)</small>		BARDP0124US 10/684,811	
		Applicant: Kai Numssen et al.	
		Filing Date	Group
		October 14, 2003	



## U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date (MM/YYYY)	Name	Class	Sub-class	Filing Date if Appropriate
	5,084,300	01/1992	Zander et al.			
	5,151,408	09/1992	Tanaka et al.			
	5,162,294	11/1992	Talvacchio et al.			
	5,712,227	01/1998	Higaki et al.			
	5,869,431	02/1999	Veal et al.			
	6,121,205	09/2000	Murakami et al.			
	6,258,472	07/2001	Neumüller et al.			

## FOREIGN PATENT DOCUMENTS

Examiner Initial	Document Number	Date (MM/YYYY)	Country	Class	Sub-class	Translation	
						Yes	No
	197 50 598	11/1997	DE				
	39 14 476	06/1990	DE				
	01063212	03/1989	JP				
	00/16412	03/2000	WO				

## OTHER ART

Examiner Initial	Author, Title, Date, Pertinent Pages, etc.
	Mukaida, Masashi et al. "In-Plane Orientation Control of C-Axis Oriented $YBa_2Cu_3O_{7-\delta}$ Films on MgO Substrates by $BaSnO_3$ Buffer Layers". <u>Japanese Journal of Applied Physics</u> . 38(1999):L926-L928.
	Geerk, J. et al. "A 3-Chamber Deposition System for the Simultaneous Double-Sided Coating of 5-inch Wafers". <u>IEEE Transactions on Applied Superconductivity</u> . 11.1(2001):3856-3858.
	Kinder, H. et al. "YBCO Film Deposition on Very Large Areas Up to $20 \times 20 \text{ cm}^2$ ". <u>Physica C</u> . 282-287(1997):107-110.
	Zou, Zhigang et al. "Superconducting $PrBa_2Cu_3O_x$ ". <u>Physical Review Letters</u> . 80.5(1998):1074-1077.

EXAMINER	DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

## Information Disclosure Statement PTO-1449 (Modified)

The identification of any reference is not intended to be, and should not be understood as being, an admission that such publication, in fact, constitutes "prior art" within the meaning of applicable law since, for example, a given reference may have a later effective date than first seems apparent or the reference may have an effective date which can be anticipated. The "prior art" status of any reference is a matter to be resolved during prosecution.  
Z:\SEC152152\DWB\BARD\IP0124\IP0124US.IDS.wpd (IDS1449.FRM) (2/97)

Concise Explanation of Relevance of Non-English Language Documents

Document DE 39 14 476 corresponds to U.S. Patent No. 5,084,300.

Document DE 197 50 598 corresponds to U.S. Patent No. 6,258,472.